



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## BIB DATA SHEET

CONFIRMATION NO. 3698

<b>SERIAL NUMBER</b> 10/549,849	<b>FILING or 371(c) DATE</b> 12/12/2005 <b>RULE</b>	<b>CLASS</b> 430	<b>GROUP ART UNIT</b> 1795	<b>ATTORNEY DOCKET NO.</b> 2005_1513A	
<b>APPLICANTS</b> Jyun Iwashita, Kanagawa, JAPAN; Toshikazu Tachikawa, Kanagawa, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/04080 03/24/2004 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-092767 03/28/2003 JAPAN 2004-051608 02/26/2004 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 03/10/2006					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /PONDER N THOMPSON RUMMEL/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 0	<b>TOTAL CLAIMS</b> 5	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> WENDEROTH, LIND & PONACK, L.L.P. 2033 K STREET N. W. SUITE 800 WASHINGTON, DC 20006-1021 UNITED STATES					
<b>TITLE</b> Negative resist composition and process for formation of resist patterns					
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		